MICHAEL O. SCHEINBERG

Patent Attorney

July 10, 2003

Fax

Name:

Examiner Chuc D. Tran

Organization:

Group Art Unit 2881

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From:

Michael O. Scheinberg

P.O. Box 164140

Austin, TX 78716-4140

Phone:

(512) 328-9510

Far:

(512) 306-1963 July 10, 2003

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APPLICANTS:

Robert L. Gerlach et al.

FILING DATE:

February 22, 2002

TITLE:

Electron Beam System Using Multiple Electron Bear is

Attached please find the following:

- 1. Information Disclosure Statement, with permission to charge Deposit Account;
- 2. Form 1449 (listing one reference); and
- 3. U.S. Patent No. 6,218,060 B1.

Michael O. Scheinberg Pat. Reg. No.: 36,919

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Mailing Address
P.O. Box 164140
Austin, Texas 78716-4140

Physical Address 3425 Bcc Cave Rd., Suite B1 Austin, Texas, 78746

Telephone: Voice: (512) 328-9510 Fax: (512) 306-1963 E-mail: mscheinberg@sgnl w.com

Att rney Docket No.: F073-2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

SERIAL NO.:

10/081,247

ART UNIT: 2821

APPLICANT:

Robert L. Gerlach, et al.

EXAMINER: Chuc Tran

FILING DATE:

February 22, 2002

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TITLE:

Electron Beam System Using Multiple Electron Beams

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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Washington, D.C. 20231

Pursuant to the guidelines for Information Disclosure Statements, 37 C.F.R. §§1.97-1.98, attached hereto is PTO Form 1449 (one sheet) with a reference listed for consideration by the Office.

In accordance with 37 C.F.R. §1.98(a), copies of the listed written references are being provided.

In accordance with 37 C.F.R. §§1.97(g)-(h), the filing of this Information Disclosure Statement shall not be construed as a representation that a search has been made or an admission that the information cited in the statement is, or is considered to be, material to patentability as defined in 37 C.F.R. §1.56(b).

This Information Disclosure Statement is being filed after the mailing of a first Office action on the merits, but before the mailing date of a final Office Action. Pursuant to 37 C.F.R. § 1.97(c)(2), permission is hereby given to charge Deposit Account 50-1635 for the fee of # 180.00 associated with the filing of this Information Disclosure Statement. A duplicate copy of this sheet is attached.

Respectfully submitted,

Date: 10 July 2003

Michael O. Scheinberg

Patent Reg. 36,919

P.O. Box 164140

Austin, Texas 78716-4140 Telephone: (512) 328-9510

Facsimile: (512) 306-1963

CERTIFICATE OF TRANSMISSION

I hereby certify that this paper or fee is being transmitted to the Commissioner for Pagents on the 16th day of July, 2003.

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT									F073-2			SERIAL NO. 10/081,247		
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*EXAMINER. Initial if citation considered, whether or not citation is in conformance with MPE. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.